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In Re Application of:	
Song et al.) Group Art Unit: 1752
Serial No.:10/720,966)) Examiner: John S. Y. Chu
Filed: November 24, 2003) Confirmation No.: 5221
For: PHOTORESIST COMPOSITION AND METHOD PATTERN FORMING USING THE SAME) TKHR Docket: 250913-1030) Top-Team: 0424-8857US)
CERTIFICATE OF FACSIMILE TRA I hereby certify that this paper (along with any paper referre on the date indicated below via facsimile to the United State 2100, facsimile number (571) 273-8300. Total number of p	ed to as being attached or enclosed) is being transmitted es Patent and Trademark Office, Technology Group

Daniel R. McClure

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

Date

The Office Action mailed December 13, 2005, has been carefully considered. In response thereto, please enter the following amendments and consider the following remarks.